In re Application of:

TADAYOSHI MUTA

Application No.: 10/052,450

Filed: January 23, 2002

For: SEMICONDUCTOR DEVICE, PRODUCTION METHOD THEREFOR, AND ELECTROPHOTOGRAPHIC APPARATUS

Docket No. 03500.016133

Examiner: Eugene Lee

Group Art Unit: 2815

Date: June 22, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED							
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	8	MINUS	20	= 0	x \$9 \$18	\$ 0.00	
INDEP. CLAIMS	5	MINUS	7	= 0	x \$43 \$86	\$ 0.00	
Fee for Mu	\$ 0.00						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0.00	

	Verified Statement claiming small entity status is enclosed, if not filed previously.
	A check in the amount of \$ is enclosed.
	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicant Damond E. Vadnais

Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3800
Facsimile: (212) 218-2200
DEV/vc

Form #120

DC\_MAIN 168689v1

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## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:			
		:	Examiner: Eugene Lee
TADAYOSHI MUTA			
		:	Group Art Unit: 2815
Application No.: 10/052,450		)	
		:	
Filed: January 23, 2002		)	
		:	
For:	SEMICONDUCTOR DEVICE,	)	
	PRODUCTION METHOD	:	
	THEREFOR, AND	)	
	ELECTROPHOTOGRAPHIC	:	
	APPARATUS	)	June 22, 2004
Mail Sto	op Amendment		
Commis	ssioner for Patents		
P.O. Bo	x 1450		
Alexand	lria, VA 22313-1450		

## **AMENDMENT**

Sir:

In response to the Office Action dated March 25, 2004, please amend the above-identified application, as follows: